Appl. No. 10/660,382 Amdt. Dated: September 15, 2008 Response to Office Action of May 15, 2008

Amendments to the Specification:

Please replace paragraph [0061] of the published application with the following amended paragraph:

[0061] The ballistically deposited samples were found to be predominately crystalline. Silicon nanoparticles were ballistically deposited on a glass substrate according to EXAMPLE 1 EXAMPLE 2. The XRD pattern of the silicon nanoparticles provided in FIG. 3 shows sharp peaks corresponding to the diamond cubic positions of crystalline silicon. The large broad peak at about 30° is probably predominately the glass substrate, but may also mask contributions from an amorphous component, for example, amorphous silicon oxide that forms readily on the surface of silicon.

Please replace paragraph [0069] of the published application with the following amended paragraph:

[0069] The nanocrystalline silicon clusters were prepared by deposition onto a nickel-coated fiberglass as described in EXAMPLE 1 EXAMPLE 2. FIG. 7 provides SEM images of the nickel-coated fibers before (FIG. 7a) and after (FIG. 7b) the silicon deposition, and after the first complete electrochemical alloying with lithium (discharge) (FIG. 7c). The nickel-coated fibers in FIG. 7a have a smooth metallic surface and are approximately 8 µm in diameter. FIG. 7b illustrates a conformal deposition of the silicon particles onto the metal-coated fibers. The nanoparticles are assembled into small islands of secondary particles (aggregates) approximately 100 nm in diameter. The smooth irregular surface of FIG. 7c suggests the formation of a passivation layer upon lithiation.

Please replace paragraph [0071] of the published application with the following amended paragraph:

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[0071] Additional electrodes of nanocrystalline silicon clusters were prepared by ballistic consolidation on a rough, planar substrate as described in EXAMPLE.1 EXAMPLE 2. The voltage profiles from electrochemical cycles 1, 25, and 50 are displayed in FIG. 8c. The differential capacity for these cycles is shown in FIG. 8d. This electrode exhibited an initial discharge capacity of 2400 mAh/g during the first insertion of lithium, and a subsequent charge capacity of 1000 mAh/g, giving a coulombic efficiency of 41% for the first cycle. This high irreversible capacity was limited to the first cycle, however. Cycles 2–50 demonstrate a stable specific capacity of approximately 1000 mAh/g (FIG. 9). The capacity fade correlates inversely with the coulombic efficiency, which was found to increase steadily up to 96% by cycle number 9 (FIG. 10). In this reversible region, the nanocrystalline electrode exhibited a mean capacity loss of approximately 20 mAh/g per cycle with a final capacity of 525 mAh/g on cycle number 50.

Please replace paragraph [0072] of the published application with the following amended paragraph:

[0072] The thin amorphous silicon films synthesized according to EXAMPLE 2 EXAMPLE 1 displayed excellent electrochemical properties. The voltage profiles obtained from cycles 1, 25, and 50 are provided in FIG. 8e. The differential capacity is provided in FIG. 8f. The initial discharge capacity of about 3500 mAh/g suggests that up to 3.6 lithium atoms per silicon atom are involved in the initial alloying. The following charge capacity of 2500 mAh/g (2.6 lithium atoms per silicon atom) yields a coulombic efficiency of 71% on the first cycle. Upon subsequent cycling, the electrode exhibited a rather stable specific capacity about 2000 mAh/g (FIG. 9). The capacity stabilization corresponds to an increase in the coulombic efficiency to 98% on cycle number 9 (FIG. 10). After 20 cycles, the amorphous thin film exhibited a mean capacity loss of only 8 mAh/g per cycle.